

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Subhendu Guha et al.

Application No.: 10/765,435

Confirmation No.: 1518

Filed: January 27, 2004

Art Unit: 2892

For: METHOD FOR DEPOSITING HIGH-
QUALITY MICROCRYSTALLINE
SEMICONDUCTOR MATERIALS

Examiner: T. Y. Tran

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Madam:

INTRODUCTORY COMMENTS

This patent application is under final rejection and it is presently under appeal. Prosecution has been closed, and pursuant to 35 U.S.C. §132, Applicant has filed a request for continuing examination to reopen prosecution of this application. In that regard, Applicant submits herewith the present amendment and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.